

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. ....10/269,302  
Priority Filing Date ..... October 11, 2002  
Inventor ..... Aaron R. Wilson  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2812  
Priority Examiner ..... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-2336  
Title ..... Method of Forming a Capacitor

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 West First Avenue, Suite 1300  
Spokane, WA 99201-3828

Please enter the following amendments prior to examining the above-identified application.

**AMENDMENTS**

**In the Title**

Please change the title to the following: --METHOD OF FORMING A  
CAPACITOR--.